In re Application of:



Docket No.: 02910.000080

SEIJI MISHIMA

Application No.: 10/665,425

Filed: September 22, 2003

For: METHOD FOR MANUFACTURING AN

ELECTRON SOURCE SUBSTRATE

Examiner: E. Pert

Group Art Unit: 2826

June 23, 2005

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	19	MINUS	20	0	x \$25 \$50	\$0.00	
INDEP. CLAIMS	5	MINUS	5	0	x \$100 \$200	\$0.00	
Fee for Mu	\$0.00						
	\$0.00						

Ш	Verified Statement claiming small entity sta	tus is enclosed, if not filed previously.
	A check in the amount of \$	is enclosed.

	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.					
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.					
	A check in the amount of \$ to cover the fee for a month extension is enclosed.					
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.					
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.					
	Respectfully submitted,					

Douglas W. Pinsky Attorney for Applicant Registration No. 46,994

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

DWP/tmc

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of:)	
11	:	Examiner: E. Pert
SEIJI MISHIMA)	
	:	Group Art Unit: 2826
Application No.: 10/665,425)	
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•	:	
For: METHOD FOR MANUFACTURING)	
AN ELECTRON SOURCE SUBSTRATE	•	June 23 2005

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

LETTER FORWARDING SUBSTITUTE SPECIFICATION

Sir:

Applicant submits herewith a substitute specification, as required by the Examiner in the Office Action dated March 23, 2005. The substitute specification incorporates changes to correct minor grammatical, idiomatic, typographical and clerical inadvertencies. A marked-up copy of the original specification, showing the matter added and deleted in the substitute specification, is also submitted herewith.

Applicant's undersigned attorney has reviewed the substitute specification and submits that the substitute specification contains no new matter.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

Attorney for Applicant Douglas W. Pinsky

Registration No. 46,994

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York, 10112-3801
Facsimile: (212) 218-2200

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